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Mikiko Tanifuji
General Manager, Scientific Information Office
National Institute for Materials Science

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CONCLUSIONS 1

○ *How to add local scientific journals to an international database* - from an 'open access' perspective:

1. Explain the open access **publishing policy** to authors
 - Why, What, How?

2. Explain **copyright issues** to authors/readers
 - Authors (and their institutions) retain copyrights, which allow authors and readers to use their published materials (full text, figures, photos, etc.) with appropriate credits and licenses.

3. Monitoring **effects of open access** research outputs
 - Who, What, Benefits?

CONCLUSIONS 2

- Any local journals should follow some global standards

Examples:

1. Journal profiles: editorial policy of review process and transparency, Editorial Board, language, etc.
2. Publication charges: \$1500 - \$3000 / article
3. Publication file format and supplementary materials
4. Metrics: citation impact, normalized impact among different disciplines
5. Copyrights: authors use CC-BY licenses in their publications and supplementary materials such as research data.

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- To help authors express their wish about derivative use of their work.



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Growth and applications of GeSn-related group-IV semiconductor materials

OPEN ACCESS **REVIEW ARTICLE**

Shigeaki Zaima^{1,2}, Osamu Nakatsuka², Noriyuki Taoka³, Masashi Kurosawa^{1,2,4}, Wakana Takeuchi² and Mitsuo Sakashita²

[+](#) [Show affiliations](#)

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